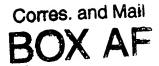
ERW)





AF/2823

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RESPONSE UNDER 37 CFR 1.116

In re Application of : **EXPEDITED PROCEDURE**

Gaku SUGAHARA, et al. : Customer Number: 20277

Serial No.: 09/890,095 : Confirmation Number: 6059

: Group Art Unit: 2828

Filed: July 27, 2001 : Examiner: Dung T. Nguyen

For: SEMICONDUCTOR LASER DEVICE, METHOD FOR FABRICATING THE

SAME, AND OPTICAL DISK APPARATUS

REQUEST FOR RECONSIDERATION

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated February 24, 2004, having a shortened statutory period for response set to expire May 24, 2004, reconsideration of the above-identified application is respectfully requested in view of the following remarks.